



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Confirmation No.: 2221  
LEE et al. Art Unit: 1753  
Application No.: 10/658,460 Examiner: S. Versteeg  
Filed: September 10, 2003 Docket No.: 101136-00095  
For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING FILM FORMING APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.121

Introductory Comments

Director of the U.S. PTO  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

August 31, 2005

Sir:

In response to the Office Action dated May 2, 2005, the period for response being extended to September 2, 2005 by the attached Petition for Extension of Time, please amend the above-titled application as follows: